

Docket No.: 1592-0163PUS1
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Masashi NAKAMURA et al.

Application No.: 10/589,733

Confirmation No.: 2225

Filed: March 22, 2007

Art Unit: 2823

For: VAPOR PHASE GROWTH METHOD

Examiner: A. K. Singal

RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated October 23, 2007, please amend the above-identified U.S. patent application as follows:

Remarks/Arguments begin on page 2 of this paper.